

Chemical bath deposition of SnS thin films from the solutions with different concentrations of tin and sulphur
Safonova, Maria; Mellikov, Enn; Mikli, Valdek; Kerm, Karin; Naidu, Revathi; Volobujeva, Olga Inter Academia 2014 - Global Research and Education 2015 / p. 183-186 : ill <http://dx.doi.org/10.4028/www.scientific.net/AMR.1117.183>

Chemical bath deposition of SnS thin films on ZnS and CdS substrates

Safonova, Maria; Nair, Padmanabhan Pankajakshy Karunakaran; Mellikov, Enn; Garcia, A. R.; Kerm, Karin; Revathi, Naidu; Romann, Tavo; Mikli, Valdek; Volobujeva, Olga Journal of materials science : materials in electronics 2014 / p. 3160-3165 : ill <https://doi.org/10.1007/s10854-014-1998-8> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

PVD grown SnS thin films onto different substrate surfaces

Revathi, Naidu; Bereznev, Sergei; Iljina, Julia; Safonova, Maria; Mellikov, Enn; Volobujeva, Olga Journal of materials science : materials in electronics 2013 / p. 4739-4744 : ill <https://doi.org/10.1007/s10854-013-1468-8> [Journal metrics at Scopus](#) [Article at Scopus](#) [Journal metrics at WOS](#) [Article at WOS](#)

SnS thin films deposition by chemical solution method and characterization = SnS õhukeste kilede sadestamine keemilisest lahusest ja saadud kilede iseloomustamine

Safonova, Maria 2016 https://www.ester.ee/record=b4535442*est

Thermal annealing of sequentially deposited SnS thin films

Safonova, Maria; Nair, Padmanabhan Pankajakshy Karunakaran; Mellikov, Enn; Aragon, Rebeca; Kerm, Karin; Naidu, Revathi; Mikli, Valdek; Volobujeva, Olga Proceedings of the Estonian Academy of Sciences 2015 / p. 488-494 : ill <http://dx.doi.org/10.3176/proc.2015.4.04>

Thin tin monosulfide films deposited with the HVE method for photovoltaic applications = Tanka plast hve kositrovega monosulfida za uporabo v fotovoltaiiki

Naidu, Revathi; Bereznev, Sergei; Lehner, Julia; Traksmaa, Rainer; Safonova, Maria; Mellikov, Enn; Volobujeva, Olga Materials and technology 2015 / p. 149-152 : ill <http://mit.imt.si/Revija/izvodi/mit151/revathi.pdf>